



PATENT
CUSTOMER NO.: 32,425

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Karin Scherer et al.

Serial No.: 10/523,951

Filed: February 8, 2005

For: METHOD FOR OBTAINING A THIN,
STABILIZED FLUORINE-DOPED
SILICA LAYER, RESULTING THIN
LAYER, AND USE THEREOF IN
OPHTHALMIC OPTICS

Group Art Unit: 2874

Examiner: Unknown

Atty. Dkt. No.: ESSR:090US

CERTIFICATE OF MAILING
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: MS AMENDMENT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

January 5, 2006

Date

Mark B. Wilson

INFORMATION DISCLOSURE STATEMENT

MS AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. §§ 1.97(g), (h), this Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

The present Information Disclosure Statement is being filed prior to the receipt of a first Official Action reflecting an examination on the merits, and hence is believed to be timely filed in accordance with 37 C.F.R. § 1.97(b). No fees are believed to be due in connection with the filing of this Information Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to these materials, the Commissioner is authorized to deduct the appropriate fees from Fulbright & Jaworski Deposit Account No.: 50-1212/ESSR:090US.

Applicants respectfully request that the listed documents be made of record in the present case.

Respectfully submitted,



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Date: January 5, 2006



Form PTO-1449 (modified)

Atty. Docket No.

Serial No.

ESSR:090US

10/523,951

List of Patents and Publications for Applicant's

Applicant

Karin Scherer et al.

INFORMATION DISCLOSURE STATEMENT

Filing Date:

Group:

February 8, 2005

2874

(Use several sheets if necessary)

U.S. Patent Documents

Foreign Patent Documents

Other Art

See Page 1

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U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1	EP 0 975 017	1/26/00	Europe			
	B2	EP 11264903	9/28/99	Japan			Abstract
	B3	JP 05215929	8/27/93	Japan			Abstract
	B4	WO 02/11195	2/7/02	WIPO			Abstract

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	Lee and Hwangbo, "Inhomogeneous refractive index of SiO ₂ thin films prepared by ion beam assisted deposition," <i>Surface and Coatings Technology</i> , 128-129:280-285, 2000.

25536164.1

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.